

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jeong-Min CHOI et al.

Serial No.: 10/750,983 Examiner: Pert, Evan T.

Filed: January 2, 2004 Group Art Unit: 2826

Confirmation No.: 5470

For: SEMICONDUCTOR DEVICE HAVING SILICIDE FORMED WITH
BLOCKING INSULATION LAYER

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE UNDER 37 CFR § 312

Responsive to the Notice of Allowance dated April 3, 2008, please amend the application as follows.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.